

MC2 ACCESS

**To research groups in
EU, associate and candidate countries:**

**We offer free access to advanced
processing for microwave electronics,
photonics and nanotechnology.**

Through an EU-financed programme we offer free access to advanced micro- and nanotechnology device processing environments for microwave and photonic devices, MEMS structures and for nanotechnology at the Department of Microtechnology and Nanoscience (MC2), Chalmers University of Technology, in Göteborg, Sweden. This offer is open for visiting researchers as well as remote users, both from universities and SMEs (small and medium size enterprises).

The facility provides means to develop process steps, process sequences, and components in small/medium quantities. In 1240 m² of clean-room area, more than 170 tools are available, including two e-beam lithography systems, silicon processing on up to 150 mm wafers, III-V and wide bandgap processing, molecular beam epitaxy, CVD and dry etching systems.

Only research groups that are entitled to disseminate the knowledge they have generated under the project are eligible to benefit from access to the infrastructure under the contract.

NOTE! The sole exception to this rule are user groups from an SME that wish to use the infrastructure for the first time.

Contract No: 026029

Contract Period: 2006-2009



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